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U.S. UTILITY Patent Application

PATENT NUMBER and
ISSUE DATE

APPL. NO.	FILING DATE	CLASS	SUBCLASS	GAU	EXAMINER
10035257	01/04/2002	438	627	2812	GUERRERO

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**CONTINUING DATA VERIFIED:

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** FOREIGN APPLICATIONS VERIFIED:
REPUBLIC OF KOREA 2001-932 01/08/2001

PG-PUB	DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>	ATTORNEY DOCKET NO
Foreign priority claimed US USC 119 conditions met		Arises <input type="checkbox"/> no Arises <input type="checkbox"/> no	262/014
Verified and Acknowledged Examiner's initials <i>M G</i>			
TITLE : Method of fabricating metal lines in a semiconductor device			

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NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Total Claims	Print Claim for O.G.
		DRAWING	
Amount Due	Date Paid	Sheets Drawn	Fig. Drawn
		Print Fig.	
ISSUE FEE		Primary Examiner	
		PREPARED FOR ISSUE	
<input type="checkbox"/> TERMINAL DISCLAIMER		Application Examiner	

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